

<b>L Number</b>	<b>Hits</b>	<b>S arch Text</b>	<b>DB</b>	<b>Time stamp</b>
-	38541	optical near2 wave guide	USPAT; EPO; JPO; DERWENT	2003/01/14 08:44
-	452	tuning with ((refractive or refractive) near2 index)	USPAT; EPO; JPO; DERWENT	2002/12/09 08:26
-	198	(optical near2 waveguide) and (tuning with ((refractive or refraction) near2 index))	USPAT; EPO; JPO; DERWENT	2002/12/09 08:27
-	387382	heater	USPAT; EPO; JPO; DERWENT	2002/12/09 08:27
-	614	charge near2 modulation	USPAT; EPO; JPO; DERWENT	2002/12/09 08:27
-	138	optical near2 rib near2 waveguide	USPAT; EPO; JPO; DERWENT	2002/12/09 08:28
-	12	confinement near2 layer	USPAT; EPO; JPO; DERWENT	2002/12/09 08:34
-	0	(tuning with ((refractive or refraction) near2 index)) with (heater and (charge near2 modulation))	USPAT; EPO; JPO; DERWENT	2002/12/09 08:29
-	4	(tuning with ((refractive or refraction) near2 index)) with (heater or (charge near2 modulation))	USPAT; EPO; JPO; DERWENT	2003/01/13 13:29
-	0	(tuning with ((refractive or refraction) near2 index)) same (charge near2 modulation)	USPAT; EPO; JPO; DERWENT	2002/12/09 08:32
-	2	(tuning with ((refractive or refraction) near2 index)) and (charge near2 modulation)	USPAT; EPO; JPO; DERWENT	2002/12/09 08:33
-	0	((optical near2 waveguide) and (tuning with ((refractive or refraction) near2 index))) and (confinement near2 layer)	USPAT; EPO; JPO; DERWENT	2002/12/09 08:34
-	2	(confinement near2 layer) and (optical near2 waveguide)	USPAT; EPO; JPO; DERWENT	2002/12/09 09:18
-	7	(tuning with ((refractive or refraction) near2 index)) with charge	USPAT; EPO; JPO; DERWENT	2002/12/09 09:21
-	3	(tuning with ((refractive or refraction) near2 index)) with geometry	USPAT; EPO; JPO; DERWENT	2002/12/09 09:29
-	3585	(periodic or quasi-periodic) with silicon	USPAT; EPO; JPO; DERWENT	2002/12/09 09:27
-	2	(tuning with ((refractive or refractive) near2 index)) and ((periodic or quasi-periodic) with silicon)	USPAT; EPO; JPO; DERWENT	2002/12/09 09:27

-	0	(tuning with ((refractive r refracti n) n ar2 ind x)) with (g m try near2 changes)	USPAT; EPO; JPO; DERWENT	2002/12/09 09:29
-	0	(tuning with ((refractive or refracti n) near2 index)) with (geom try near2 chang\$3)	USPAT; EPO; JP ; DERWENT	2002/12/09 09:30
-	0	(tuning with ((refractive or refraction) near2 index)) with (charge near2 modulation)	USPAT; EPO; JPO; DERWENT	2003/01/13 13:30
-	0	(tuning with ((refractive or refraction) near2 index)) same (charge near2 modulation)	USPAT; EPO; JPO; DERWENT	2003/01/13 13:31
-	2	(tuning with ((refractive or refraction) near2 index)) and (charge near2 modulation)	USPAT; EPO; JPO; DERWENT	2003/01/13 13:35
-	4247	385/2,8,10,37,129,130,132.ccls.	USPAT; EPO; JPO; DERWENT	2003/01/13 13:35
-	1627	385/2,8,10,37,129,130,132.ccls. and reflection	USPAT; EPO; JPO; DERWENT	2003/01/13 13:36
-	6568	(charge or voltage) near2 modulation	USPAT; EPO; JPO; DERWENT	2003/01/13 13:37
-	128	385/2,8,10,37,129,130,132.ccls. and ((charge or voltage) near2 modulation)	USPAT; EPO; JPO; DERWENT	2003/01/13 13:37
-	19	(385/2,8,10,37,129,130,132.ccls. and reflection) and polysilicon	USPAT; EPO; JPO; DERWENT	2003/01/13 14:00
-	2	6363202.pn.	USPAT; EPO; JPO; DERWENT	2003/01/13 13:55
-	0	(385/2,8,10,37,129,130,132.ccls. and ((charge or voltage) near2 modulation)) and polysilicon	USPAT; EPO; JPO; DERWENT	2003/01/13 14:05
-	660649	silicon or polysilicon	USPAT; EPO; JPO; DERWENT	2003/01/13 14:05
-	3676	bragg near2 grating	USPAT; EPO; JPO; DERWENT	2003/01/13 14:06
-	69	(silicon or polysilicon) same (bragg near2 grating)	USPAT; EPO; JPO; DERWENT	2003/01/13 14:08
-	94060	waveguide	USPAT; EPO; JPO; DERWENT	2003/01/13 14:08
-	63	((silicon or p lysilic n) same (bragg near2 grating)) and wav guide	USPAT; EPO; JPO; DERWENT	2003/01/13 14:08
-	7911	wav guid same (charg r voltag )	USPAT; EP ; JPO; DERWENT	2003/01/14 09:27

-	321	(waveguide same (charge or voltage)) same tuning	USPAT; EPO; JPO; DERWENT	2003/01/14 09:28
-	51	((waveguide same (charge or voltage)) same tuning) same ((refraction or refractive) near2 index)	USPAT; EPO; JPO; DERWENT	2003/01/14 09:28
-	0	((waveguide same (charge or voltage)) same tuning) same ((refraction or refractive) near2 index)) same insulator	USPAT; EPO; JPO; DERWENT	2003/01/14 08:48
-	1	((waveguide same (charge or voltage)) same tuning) same ((refraction or refractive) near2 index)) and insulator	USPAT; EPO; JPO; DERWENT	2003/01/14 08:48
-	22	((waveguide same (charge or voltage)) same tuning) same ((refraction or refractive) near2 index)) and bragg	USPAT; EPO; JPO; DERWENT	2003/01/14 08:50
-	4575	waveguide same (silicon or polysilicon)	USPAT; EPO; JPO; DERWENT	2003/01/14 09:28
-	34	(waveguide same (silicon or polysilicon)) same tuning	USPAT; EPO; JPO; DERWENT	2003/01/14 09:28
-	3	((waveguide same (silicon or polysilicon)) same tuning) same ((refraction or refractive) near2 index)	USPAT; EPO; JPO; DERWENT	2003/01/14 09:28